Application/Control No.	Applicant(s)/Patent under Reexamination
10/017,325	SHIBATA ET AL.
Examiner	Art Unit
Junghwa M. Im	2811

SEARCHED				
Class	Subclass	Date	Examiner	
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
As	above	1/18/2006	JMI		
see search history printout					

SEARCH NOT	TES STRATEGY)
	DATE	EXMR
EAST (uspat, uspub, jpo, epo, der, ibm)	1/18/2006	JMI
		